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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

LI et al   Atty. Ref.:   36-1900

Serial No. 10/535,621   TC/A.U.:   2613

Filed: May 20, 2005   Examiner: Unknown

For: METHOD AND SYSTEM FOR ESTIMATING GLOBAL MOTION IN
VIDEO SEQUENCES

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June 16, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

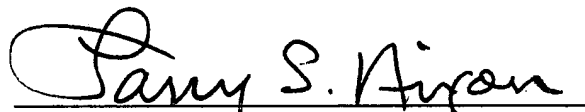## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Further to the Information Disclosure Statement filed October 13, 2005, the
remainder of the missing documents from the listed attached to the Information
Disclosure Statement have now been obtained and are attached together with a further
PTO-1449.

Consideration of each reference and return of an initialed copy of the attached
form signifying same is requested.

Respectfully submitted,

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PTO/SB/08a

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

ATTY. DOCKET NO.	SERIAL NO.
36-1900	10/535,621

APPLICANT

LI et al

FILING DATE	TC/A.U.
May 20, 2006	2613

(stamp: OIPE JUN 16 2006 PATENT & TRADEMARK OFFICE)

U.S. PATENT DOCUMENTS
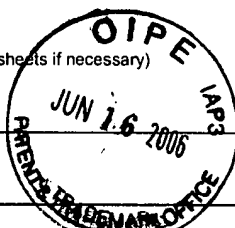
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	NO

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

	Hampel et al, ?The Approach Based on Influence Functions, ROBUST STATISTICS, John Wiley & Sons Inc., 1986
	Huber, ROBUST STATISTICS, John Wiley & Sons, 1981
	Meer et al., "Robust Regression Methods for Computer Vision: A Review, International Journal of Computer Vision, 6(1):59-70, 1991
	Meer et al., "robust Computer Vision: An Interdisciplinary Challenge, COMPUTER VISION AND IMAGE UNDERSTANDING, 78:1-7, 2000
	Meng et al, "CVEPS:A Compressed Video Editing and Parsing System", In ACM MULTIMEDIA, 1996

*Examiner		Date Considered	

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.